



ELECTRONIC COPY

LG814645765
Report verification at igi.org



July 2, 2026
IGI Report Number **LG814645765**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **HEXAGONAL MODIFIED STEP CUT**
Measurements **10.66 X 5.55 X 3.39 MM**
GRADING RESULTS
Carat Weight **1.59 CARAT**
Color Grade **D**
Clarity Grade **VVS 2**

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GRADING RESULTS

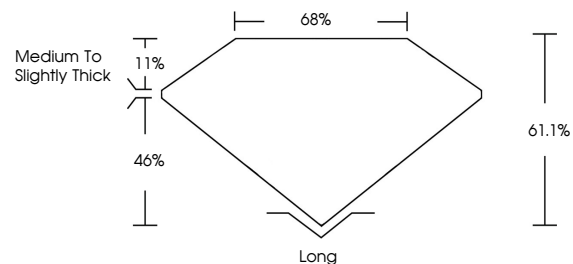
Carat Weight **1.59 CARAT**
Color Grade **D**
Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG814645765**

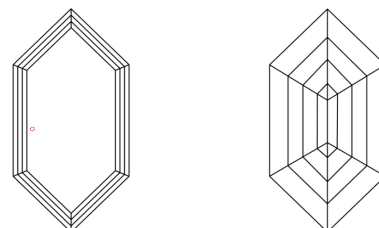
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

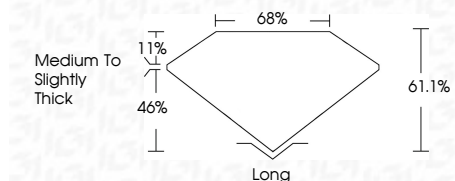
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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HEXAGONAL MODIFIED STEP CUT
10.66 X 5.55 X 3.39 MM
1.59 CARAT
Color Grade D
Clarity Grade VVS 2
Depth 61.1%
Table 68%
Girdle Medium to Slightly Thick
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG814645765
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa